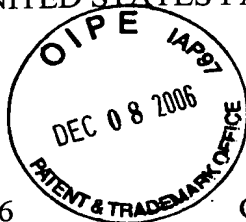


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IFW

In re patent application of

Lin HAI, et al.



Serial No.: 10/573,446

Group Art Unit: 2871

Filed: March 24, 2006

Examiner: Unknown

For: PLASMA DISPLAY PANEL AND METHOD OF  
MANUFACTURING SAME

Honorable Commissioner of Patents  
Alexandria, Virginia 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to Applicants' duty of disclosure under 37 CFR §1.56, Applicants respectfully bring the following documents cited in the International Search Report (previously filed on July 13, 2006) in a counterpart foreign application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Further, Japanese No. JP2002-033053 corresponds to US Patent No. 6,788,373. Also, JP2003-031130 corresponds to US Patent No. 6,674,238, and JP Hei 10-233157 corresponds to US Patent Nos. 6,013,309 and 6,379,783.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which Applicants are aware.

In compliance with the concise explanation requirement under 37 CFR §1.98(a)(3) for foreign language documents, Applicants enclose herewith a copy of the International Search Report citing such documents, together with an English-language version (if not already included) of that portion of the Search Report indicating the degree of relevance found by the foreign office. Further, English language abstracts are attached to the references.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

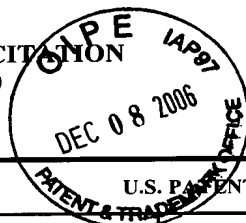
Sean M. McGinn, Esq.  
Registration No. 34,386

Date: 12/8/06

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# INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)



Docket Number (Optional) <b>04-41 PUS</b>	Application Number <b>10/573,446</b>
Applicant(s) <b>Lin HAI, et al.</b>	
Filing Date <b>March 24, 2006</b>	Group Art Unit <b>2871</b>

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,013,309	01/11/2000	Kim, et al.			
		US 6,788,373 B2	09/07/2004	Ito, et al.			
		US 6,674,238 B2	01/06/2004	Otani, et al.			
		US 6,379,783 B1	04/30/2002	Kim, et al.			

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2003-31130	01/03/2003	Japan			ABS	
		2002-33053	01/31/2002	Japan			ABS	
		10/233157	09/02/1998	Japan			ABS	
		7-37510	02/07/1995	Japan			ABS	
		2000-156153	06/06/2000	Japan			ABS	

## OTHER DOCUMENTS

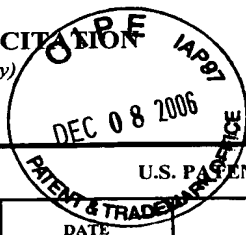
(Including Author, Title, Date, Pertinent Pages, Etc.)

		International Search Report dated January 18, 2005

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)



Docket Number (Optional) <b>04-41 PUS2001</b>	Application Number <b>10/573,446</b>
Applicant(s) <b>Lin HAI, et al.</b>	
Filing Date <b>March 24, 2006</b>	Group Art Unit <b>28717</b>

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	7-296718	11/10/1995	Japan			ABS	
	9-167566	06/24/1997	Japan			ABS	
	8-287823	11/01/1996	Japan			ABS	
	7-192630	07/28/1995	Japan			ABS	
	2001-76629	03/23/2001	Japan			ABS	

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER	DATE CONSIDERED
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